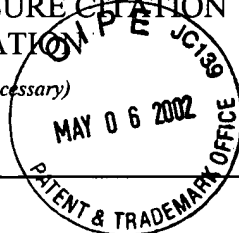


Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Docket Number: 361752000500	Application Number: 09/715,013
	Applicant Keunsuk P. CHANG et al.	
	Filing Date: November 20, 2000	Group Art Unit: 1774
	Mailing Date: May 6, 2002	



U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
KA	1.	A. Yializis et al., 1997 "Barrier Degradation in Aluminum Metallized Polypropylene Films" Society of Vacuum Coaters 505/856-7188, pp 371-375.
KA	2.	F. Casey et al., 1999 "Properties of Metallized Film in a Free Span Web Metallizer" Society of Vacuum Coaters 505/856-7188, pp 480-483.
KA	3.	U. Moosheimer et al., 1999 "Permeation of Oxygen and Moisture Through Vacuum Web Coated Films" Society of Vacuum Coaters 505/856-7188, pp 408-414.
KA	4.	J. Specht, 1998 "Metallization: An End-User's Perspective" Society of Vacuum Coaters 505/856-7188, pp 440-445.
KA	5.	Y. Leterrier et al. 1998 "Durability of Thin PECVD SiO _x Coatings on Polymer Films" Society of Vacuum Coaters 505/856-7188, pp 429-433.

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EXAMINER: (examiner) <i>Kimberly Nguyen</i>	DATE CONSIDERED: <i>7/11/02</i>
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